

DOCKET NO: VSEA 26-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Steven R. Walther

Serial No:

10/006,462

Confirmation No:

5689

Filed:

December 4, 2001

For:

DOSE UNIFORMITY CONTROL FOR PLASMA DOPING

SYSTEMS

Examiner:

Michelle Crowell

Art Unit:

1763

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 4th day of August, 2006.

Janine Canillas

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Petition for Three-Month Extension of Time

A three-month extension of time, to and including August 6, 2006, is requested in response to the Examiner's Office Action of February 6, 2006.

Please charge the extension fee of \$1,020.00 to deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted, Steven R. Walther, Appliant

08/10/2006 MGEBREM1 00000022 500896 10006462

02 FC:1253

1020.00 DA

Scott Faber, Reg. No. 48,380

Varian Semiconductor Equipment

Associates, Inc. 35 Dory Rd.

Gloucester, Massachusetts 01930-2297

Telephone: (978) 282-5818

Docket No. VSEA 26-00